EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	13	"6,369,957"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:08
L2	18697	Optical same lithography	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:54
L3	3	2 and (solid adj immersion adj lens near2 layer)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:16
L4	3	2 and (immersion adj lens near2 layer)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:49
L5	209	2 and (lens near2 layer)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:51
L6	3	5 and (solid adj immersion adj lens near2 layer)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:20
L7	10	5 and (layer near4 movement)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:52

10/538,115

L8	0	(helmar-van-santen).IN.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:37
L9	0	(santen-van-h).IN.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:38
L10	19	(santen-h-v).IN.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:46
L11	103	5 and (gas near4 removal or flow)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:46
L12	6	11 and (layer near4 movement)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:48
L13	14517	((250/492.10,216,234,235,) or (359/619,581,) or (369/44.14,112,) or (430/311,322,)).CCLS.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/07/18 10:49
L14	5	13 and (immersion adj lens near2 layer)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:49

L15	103	11 and (lens near2 layer)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:51
L16	6	15 and (layer near4 movement)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:52
L17	0	(optical same lithography) and (solid adj immersion adj lens near4 layer) and (layer near4 movement) and (irrad$5 near4 portions or segments) and (liquid near4 interspace) and (remov$3 near4 liquid) and (remov$3 or displace near4 gas adj flow).clm.	US-PGPUB; USPAT	AND	ON	2007/07/18 10:58